

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: )  
Shinji MAEKAWA et al. ) Confirmation No.: 3488  
Application No. 10/579,800 ) Examiner: TBA  
Filed: May 19, 2006 ) Group Art Unit: 2629  
For: ELECTRIC APPLIANCE )  
SEMICONDUCTOR DEVICE, AND ) Date: May 16, 2008  
METHOD FOR MANUFACTURING  
THE SAME

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. To assist the Examiner, the documents to be considered are listed on the attached form PTO-1449.

Applicants wish to note that the reference noted on the attached PTO-1449 was previously disclosed in the Office Action of Chinese Application No. 200580003270.7 issued by the Chinese Patent Office on February 22, 2008.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application, and that an Examiner-initialed copy of this form be returned to the undersigned.

Respectfully submitted,

**NIXON PEABODY LLP**

Date: May 16, 2008

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